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High performance broadband self-driven photodetector based on MX ene $(Ti_3C_2T_x)/GaAs$ Schottky junction



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HIGHLIGHTS

- Ti₃C₂T_x/GaAs Schottky junction photodetector is prepared by simply dripping Ti₃C₂T_x MXene solution on GaAs substrate.
- High responsivity of ~1.46 A/W, specific detectivity of ~1.23 \times 10¹³ Jones are obtained when the device is operated in self-driven mode.
- The photodetector exhibits a broadband response spectrum up to 980 nm due to plasmon-induced hot electrons in Ti₃C₂T_x MXene film.

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ABSTRACT

As a novel family of 2D materials, MXenes are supposed to play a vital role in optoelectronic devices and systems due to their high conductivity, good optical properties, and favorable compatibility with water and organic solvents. However, the application of MXenes in highly sensitive photodetection is far scarcely investigated. Here, we demonstrate high-quality $Ti_3C_2T_x/GaAs$ Schottky junction by simply dripping $Ti_3C_2T_x$ MXene solution on a pre-patterned GaAs substrate. Owing to the wide absorption of MXene and the good quality junction, the self-driven $Ti_3C_2T_x/GaAs$ Schottky junction photodetector with an impressive performance is realized. The assembled photodetector exhibits a high sensitivity over a wide waveband with a good responsivity of ~1.46 A/W, a large specific detectivity of ~1.23 × 10¹³ Jones, and a high I_{iight}/I_{dark} ratio of 5.6×10^5 . Significantly, the photodetector is capable of sensing infrared light signal up to 980 nm which exceeds the absorption edge of GaAs (874 nm) due to the generation of hot electrons in $Ti_3C_2T_x$ MXene film. Given the superior device performance along with a simple and facile fabrication method, the $Ti_3C_2T_x/GaAs$ Schottky junction photodetector may find the great potential in high performance broadband, self-driven photodetector applications.

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1. Introduction

Recently, a new class of two-dimensional (2D) materials, such as transition metal carbides, nitrides and carbon nitrides (MXenes), have attracted worldwide attention due to their rich chemical and physical properties [1-3]. The chemical formula of MXenes is M_{n+1} - X_nT_x (n = 1, 2, or 3), where M represents transition metal (e.g., Sc, Ti, Zr, Hf, Nb, Ta, Cr, Mo, Mn), X denotes C and/or N, T_x is surface functional group (e.g., hydroxyl, oxygen or fluorine) [4–7]. So far, over 30 different kinds of MXenes have been experimentally obtained and many more MXenes are theoretically predicted to exist [8-11]. MXenes have been found to demonstrate tailorable and excellent properties due to their abundant surface functional groups and stoichiometry. Especially, MXenes have been proved to have high optical transmittance in visible light region. $Ti_3C_2T_x$, in particular, has shown a transmittance of ~93% with a conductivity of ~5736 S cm⁻¹ when its thickness is down to ~4 nm [12,13]. Also, the large tunability of work functions from ~2.14 eV to ~5.65 eV could be readily to achieve, covering a wide range of metals [14]. Benefiting from these appealing properties, outstanding photodetection performance has been demonstrated based on MXenes in previous studies [14,15]. Meanwhile, optical and electronic properties of MXenes are considered to be tailored by the surface terminations, transition metals, electrochemical intercalation, thickness and so on [16]. Consequently, these excellent optoelectronic properties, combined with hydrophilia, high transmittance, and high electrical conductivity make MXenes attractive and promising candidates for the important applications in optoelectronic devices and systems, such as energy storage and conversion devices [17], electromagnetic interference (EMI) shielding layer [18], transparent conductors [12,19], photovoltaic devices [9], light emitting diodes (LEDs) [20], photodetectors [14], etc.

Photodetector, as one of the most essential and important optoelectronic devices, can convert incident light into electrical signal, having wide-ranging applications including image sensing, night vision, communication and so on [21,22]. Thanks to their high conductivities, transparence, and hydrophily, the wide usage of MXenes in photodetectors has been demonstrated. For instance, Nabet et al. fabricated MXene-GaAs-MXene photodetectors by simply spin-coating transparent Ti₃C₂-based MXene electrodes on a purpose-designed GaAs in order to replace high-cost Au electrodes, which exhibited better photodetection performance than the counterpart device with Au electrode [23]. In addition, an allsprayed-processable and large-area flexible photodetector by spraving both 2D CsPbBr₃ nanosheets and Ti₃C₂T_x MXene on the paper substrate was assembled, and a high on/off ratio of $\sim 2.3 \times 10^3$ as well as a fast response time of ~ 18 ms were obtained. Importantly, the flexible photodetector could still maintain an excellent stability after 1500 cycles bending operation [24]. Very recently, it has been reported that Mo_2CT_x , $Ti_3C_2T_x$, Nb_2CT_x , T_2CT_x , and V_2CT_x showed superior photodetection characteristics because of light-matter interaction in MXenes materials and dephasing of surface plasmon with a short lifetime in several studies [15]. Specially, all kinds of MXenes including Mo_2C , TiC, Ti_2CT_x combined with different semiconductors (e.g. MoS₂, TiO₂, ZnO, CdS, and Zn₂GeO₄) have been widely applied in high performance photodetectors, demonstrating the great potential in next-generation optoelectronic system applications [25-30].

Enlightened by these research works, we have developed a high-quality $Ti_3C_2T_x/GaAs$ Schottky junction by simply dripping $Ti_3C_2T_x$ MXene solution on a pre-patterned GaAs substrate for a highly sensitive detection in multiband wavelength region. The assembled self-driven $Ti_3C_2T_x/GaAs$ Schottky junction photodetector displays an excellent photodetection performance in term of a good responsivity of ~1.46 A/W, an impressive specific detectivity

of ~ 1.23×10^{13} Jones, a high $I_{\text{light}}/I_{\text{dark}}$ ratio of 5.6 $\times 10^5$. Significantly, the photodetector exhibits a broadband response spectrum up to 980 nm which exceeds the absorption edge of GaAs due to the generated hot electrons in Ti₃C₂T_x MXene film. These impressive findings together with a simple and facile preparation method make the present Ti₃C₂T_x/GaAs Schottky junction photodetector a building block for the further optoelectronic devices and systems applications.

2. Experimental section

Material Synthesis and Characterization: The $Ti_3C_2T_x$ MXene was synthesized from Ti_3AlC_2 MAX phase by etching the Al layers from the MAX phase (XFK01, XFK02, XFNANO). The morphologies of the obtained $Ti_3C_2T_x$ MXene was characterized by scanning electron microscope (SEM), and transmission electron microscopy (TEM). X-ray diffraction (XRD) and X-ray photoelectron spectroscopy (XPS) were used to study their structure and composition.

Device Fabrication and Characterization: To assemble $Ti_3C_2T_x/$ GaAs Schottky junction, a ~80 nm Al₂O₃ insulating layer was firstly deposited on a rinsed n-type GaAs substrate (0.5 \times $10^{-3}\text{--}10^{-3}~\Omega$ cm, $\langle 100 \rangle$) using photolithography and atomic layer deposition techniques to form a window (0.5 cm \times 0.5 cm). Then the prepared Ti₃C₂T_x MXene solution (XFK02, few layer nanoflakes) was dropped on the well-defined GaAs substrate. After naturally drying at room temperature in the air, Ag paste was painted at the edge of $Ti_3C_2T_x$ MXene film while In/Ga alloy as paste was painted on the back side of *n*-type GaAs as the electrode for measurement. Furthermore, the electrical and photoresponse measurements of the device were conducted at room temperature by a semiconductor characterization system (Keithley 4200) attached with different laser diodes (405, 650, 780, 808, 980 nm). The temperature-dependent electrical measurement was carried out by a Keithley 2636B source meter (Tektronix, USA) attached with a physical property measurement system (VersaLab, Quantum Design).

3. Results and discussion

Fig. 1a shows the typical SEM image of $Ti_3C_2T_x$ MXene (multilayer nanoflakes, XFK01), which reveals an accordion-like multilayered nanostructure with abundant open edges, indicating the successful synthesis of Ti₃C₂T_x MXene. According to TEM image of $Ti_3C_2T_x$ MXene in Fig. 1b, the few layer $Ti_3C_2T_x$ nanoflakes have a lateral size of several hundreds of nanometers with clean and flat surface. In Fig. 1c, the XRD studies reveal that the five diffraction peaks located 6.77°, 21.48°, 34.30°, 41.85°, 61.00° can be indexed to the (002), (006), (101), (105) and (110) crystal planes of Ti_3C_2 - T_x MXene, while the peak of (104) was not observed, indicating the successful preparation of few layer Ti₃C₂T_x MXene and the existence of surface functional groups [3,31]. In addition, Fig. 1d-e shows XPS spectra of Ti 2p and C 1s core levels. For Ti 2p spectra, it consists of two peaks located at 454.8 eV (Ti2p_{3/2}) and 460.7 eV $(Ti2p_{1/2})$, indicating the bonding energy between Ti and C in Ti_3C_2 -T_x MXene, respectively [9,32]. Besides, two peaks at 280.7 eV and 285.1 eV in the C1s core levels are considered to be related to Ti-C bond and C-C bond, respectively (Fig. 1e) [33]. All these basic characterizations collectively confirm that the few-layer $Ti_3C_2T_x$ nanoflakes with high quality were successfully obtained from a simple and general etching approach.

Fig. 2a schematically presents the crystal structure of $Ti_3C_2T_x$ MXene and the step-wising fabrication process of $Ti_3C_2T_x$ /GaAs Schottky junction device are shown in Fig. 2b–d. Next, we studied the electrical characteristics of the $Ti_3C_2T_x$ /GaAs Schottky junction. Fig. 3a shows the typical current–voltage (*I-V*) characteristic curve



Fig. 1. (a) Typical SEM image of Ti₃C₂T_x multilayer nanoflakes. (b) The representative TEM image of Ti₃C₂T_x few layer nanoflakes. (c) XRD pattern of Ti₃C₂T_x MXene. (d-e) Ti₂P and C1s XPS spectra of Ti₃C₂T_x MXene, respectively.



Fig. 2. (a) The schematic of the $Ti_3C_2T_x$ MXene. (b) - (d) The step-wising fabrication process of $Ti_3C_2T_x$ /GaAs Schottky junction device.

of Ti₃C₂T_x/GaAs Schottky junction in the dark at room temperature. In addition, the inset of Fig. 3a depicts the cross-sectional schematic of the device and the semi-logarithmic *I-V* curve. One can easily find that the device exhibits a pronounced rectifying behavior with a high rectification ratio of ~55 at ± 1 V due to the formation of Schottky junction at Ti₃C₂T_x/GaAs interface. The *I-V* characteristic of the Ti₃C₂T_x/GaAs Schottky junction is studied by using the following equation:

$$I = I_0[\exp\left(\frac{qV}{nk_BT}\right) - 1] \tag{1}$$

where I_0 , q, n, T, and k_B are the reverse saturation current, the quantity of a positive charge, the ideality factor, the absolute temperature and the Boltzmann constant, respectively. Subsequently, n is determined to be ~2.19 based on equation of $n = \frac{q}{k_B T} \frac{dv}{dlnl}$, which is slightly higher than ideal value (n = 1), but smaller than many reported heterojunction photodetectors based on graphene/GaAs and single-walled carbon nanotube/GaAs heterojunctions [34,35], indicating the high junction quality. In addition, the electrical properties of the junction could be investigated by an equivalent circuit model consisting of a resistor and an ideal diode (the inset of



Fig. 3. (a) The *I-V* curve of a typical $Ti_3C_2T_x/GaAs$ Schottky junction in the dark at room temperature. The inset depicts the cross-sectional schematic of the device and the semi-logarithmic *I-V* curve. (b) dV/dI versus 1/I curve taken from the data in figure (a), the inset shows the equivalent circuit model of the heterojunction consisting of serially connected diode and resistor. (c) The temperature-dependent *I-V* curves in the range of 230–330 K with an interval of 20 K. (d) Richardson plot, $ln(I_0/T^2)$ versus 1000/T for the Ti₃C₂T_x/GaAs Schottky junction.

Fig. 3b) [36,37]. The voltage across the resistor and the ideal model could be defined by the following equation:

$$V = IR + \frac{nk_BT}{q}\ln(\frac{I}{I_0})$$
⁽²⁾

Moreover, a differential resistance could be obtained by differentiating Eq. (2) with respect to the current.

$$\frac{dV}{dI} = R + \frac{nk_BT}{qI} \tag{3}$$

The dV/dI versus 1/I curve is shown in Fig. 3b. Their linear relationship implies that the effectiveness of the equivalent circuit model. Furthermore, the series resistance of the device is deduced to be ~4 K Ω . This value is much lower than that of heterojunction constructed by SnO₂ nanowire/Si and SWCNTs/SnO₂ and confirms the high-quality Schottky junction electrical performance [38,39].

To better understand the carrier transportation mechanism of the $Ti_3C_2T_x/GaAs$ Schottky junction, temperature-dependent electrical measurements have been performed. Fig. 3c shows the temperature-dependent *I-V* curves in the range of 230–330 K with an interval of 20 K. The current gradually raises with the increasing temperature, indicating a good dependence of the electrical transport properties on temperature. According to the Eq. (1) combined with thermionic emission (TE) model, the saturation current can be described as [40,41]:

$$I_0 = A^* T^2 [exp \frac{-q \varnothing_B}{kT}] \tag{4}$$

where *A*, *A*^{*}, and \mathscr{D}_B are the effective device area (*A* = 0.25 cm²), the effective Richardson constant of the GaAs, and the Schottky barrier height (SBH), respectively. Furthermore, Fig. 3d depicts the Richardson plot of $\ln(I_0/T^2)$ as a function of 1000/T for the Ti₃C₂T_x/GaAs Schottky junction, from which one can easily see that the good linearity of the $\ln(I_0/T^2)$ versus 1000/T plot between 230 K and 330 K,

in good agreement with Richardson-Schottky (RS) model [42]. The effective Richardson constant of A^* could be obtained by Eq. (5):

$$\ln \frac{I_0}{T^2} = \ln \left(AA^*\right) - \frac{q \bigotimes_B}{kT} \tag{5}$$

From the plot shown in Fig. 3d, the SBH value could be deduced to be ~0.15 eV, while *A*^{*} was determined as 1.36×10^{-4} A/m² K². The *A*^{*} value obtained here is much lower than the previously reported value of n-type GaAs (0.41 × 10⁴ A/m² K²) [43,44]. The large deviation indicates a barrier inhomogeneity and potential fluctuations prevailing at the Schottky interface [45,46].

Furthermore, the photodetection performance of the $Ti_3C_2T_x/$ GaAs Schottky junction photodetector was systemically evaluated by using a 650 nm laser diode (LD). Panel a and b of Fig. 4 depict the I-V curves under the dark condition and 650 nm light illumination with different light intensities from 4.5 μ W/cm² to 15.2 mW/ cm². Apparently, the current in reverse bias region is found to increase sharply with the increase of light intensity. Careful examination finds that the device shows an obvious photovoltaic effect with an open-circuit voltage (V_{OC}) of 0.37 V and a short circuit current (I_{SC}) of 7.94 \times 10⁻⁵ A at a light intensity of 15.2 mW/cm², rendering the photodetector operate in self-driven mode. On the other hand, The $I_{\text{light}}/I_{\text{dark}}$ ratio of the Ti₃C₂T_x/GaAs Schottky junction as a function of various light intensities is shown in Fig. 4c. Under the same light intensity, the device shows the maximum $I_{\text{light}}/I_{\text{dark}}$ ratio at zero bias. Specially, the $I_{\text{light}}/I_{\text{dark}}$ ratio at zero bias increases with the increase of the light intensity, ranging from 5.7 \times 10² at 4.5 $\mu W/cm^2$ to 5.6 \times 10^5 at 15.2 $mW/cm^2.$ The corresponding photovoltaic photoresponse of the photodetector under a pulsed 650 nm light irradiation with various power intensities was studied in Fig. 4d. Obviously, the Ti₃C₂T_x-based Schottky junction photodetector can be easily and reversibly switched between high and low current states with excellent reproducibility and stability, yielding the highest $I_{\text{light}}/I_{\text{dark}}$ ratio of 5.6 \times 10⁵ at light intensity



Fig. 4. (a) The *I*-V curves under the dark condition and 650 nm light illumination with various light intensity from 4.5 μ W/cm² to 15.2 mW/cm². The inset of figure (a) shows the *I*-V curves under 650 nm light illumination with some low light intensities. (b) The light intensity dependent *I*-V curves in semi-log coordinates. (c) The *I*_{light}/*I*_{dark} ratio of the Ti₃C₂T_x/GaAs Schottky junction with various light intensities. (d) Photovoltaic photoresponse of the photodetector under a pulsed 650 nm light irradiation with various power intensities. (e) Plots of the photocurrent as a function of light intensity. (f) Light intensity-dependent responsivity and specific detectivity.

of 15.2 mW/cm². Importantly, I_{light}/I_{dark} ratio could be as high as 5.7×10^2 at a very low power intensity of 4.5 μ W/cm², suggesting the perspective of weak light signal detection. Furthermore, the photocurrent defined as difference of current under light illumination and dark condition (I_{ph} , $I_{ph} = I_{light} - I_{dark}$) at zero bias versus the incident light intensity (*P*) is presented in Fig. 4d and e. By analyzing the dependence of photocurrent on light intensity with the use of a power law of $I_{ph} \propto P^{\theta}$ (θ determines the photoresponse to light intensity), a power exponent of $\theta = 0.95$ is obtained [47]. This calculated value is very close to 1, indicating the presence of some trap states between the conduction band edge and the Fermi level [48].

To quantitatively characterize the photodetection performance of the self-driven $Ti_3C_2T_x/GaAs$ Schottky junction photodetector, two important figures of merit such as responsivity (*R*) and specific detectivity (*D*^{*}) are calculated according to the following equations [49,50]:

$$R = I_{ph}/PS \tag{6}$$

$$D^* = \sqrt{\frac{A}{2qI_{dark}}}R\tag{7}$$

where *S* and *A* are the effective illuminated area (0.01 cm²) and the effective device area (0.25 cm²), respectively. Both *R* and *D** as a function of the incident light intensity (650 nm, zero bias) are plotted in Fig. 4f. It is observed that both values show the decreasing intendency with the increase of light intensity, which could be attributed to the intensified carrier recombination at a higher light intensity [51]. Specifically, the maximum *R* and *D** of the Ti₃C₂T_x-based device are deduced to be 1.46 A/W and 1.23 × 10¹³ Jones (1 Jones = 1 cm Hz^{1/2} W⁻¹) at a relatively low light intensity of 4.5 μ W/cm², respectively, which are not only superior to previously reported GaAs-based Schottky junction photodetectors, but also much better than optoelectronic devices based on Mxenes (Table 1) [14,23,24,34,35,52].

The photoresponse properties of the $Ti_3C_2T_x/GaAs$ Schottky junction photodetector are found to greatly depend on the incident light. Fig. 5a depicts the time-dependent photovoltaic photoresponse of the device under different wavelength light signals. It is obvious that the device shows the fast response to light signal from 405 nm to 980 nm, suggesting the $Ti_3C_2T_x/GaAs$ Schottky junction photodetector is highly sensitive over a multiple spectrum range. As a matter of fact, with the reduction of the light intensities for different wavelengths, the photocurrents also decrease mono-

Table 1

Comparison of the device performance of MXene-based and GaAs-based photodetectors.

Device structre	Response wavelength (nm)	I _{light} /I _{dark} Ratio	Responsivity	Detectivity(Jones)	Self-driven?	Refs
Ti ₃ C ₂ T _x /GaAs Schottky junction photodetector Ti ₃ C ₂ T _x /n-Si Schottky junction photodetector Mxene-GaAs-Mxene Photodetector Perovskite/MXene-Based Photodetector Graphene/AIO _x /GaAs photodetector	405-980 405 532, 780, 830 450 850 405 1064	5.6×10^{5} 10^{5} - 2.3×10^{3} 10^{5}	1.46 A/W 26.95 mA/W 278 mA/W 44.9 mA/W 5 mA/W 274 mA/W	$\begin{array}{c} 1.23 \times 10^{13} \\ - \\ 11.6 \times 10^{10} \\ 6.4 \times 10^{8} \\ 2.98 \times 10^{11} \\ 7.6 \times 10^{12} \end{array}$	Yes Yes No No Yes	This work [14] [23] [24] [34] [25]
AgNPs/graphene/GaAs heterostructure photodetector	325-980	_	210 mA/W	2.98×10^{13}	Yes	[52]



Fig. 5. (a) The time-dependent photovoltaic photoresponse of the device under different wavelength light signals. (b) The energy band diagram of the Ti₃C₂T_x/GaAs Schottky junction.



Fig. 6. (a and b) *I-V* characteristics and time-dependent photoresponses of the $Ti_3C_2T_x/GaAs$ Schottky junction photodetector after a month storage in air condition. (c) Stability of the $Ti_3C_2T_x/GaAs$ Schottky junction photodetector with more than 1000 cycles. (d) One normalized cycle measured to estimate rise/fall time.

tonously. The current is found to raise from 1.43×10^{-10} A to 6.97×10^{-5} A (405 nm, 14.9 mW/cm²), 7.94×10^{-5} A (650 nm, 15.2 mW/cm²), 4.32 \times 10^{-5} A (780 nm, 18.4 mW/cm²),

6.89 \times 10⁻⁵ A (808 nm, 25.4 mW/cm²), and 3.40 \times 10⁻⁵ A (980 nm, 17.9 mW/cm²), respectively, giving rise to a highest $I_{\rm light}/I_{\rm dark}$ ratio of 5.6 \times 10⁵ at 650 nm (15.2 mW/cm²). It should be noted

that the device exhibits a high sensitivity to 980 nm light illumination, which exceeds the absorption edge of GaAs (874 nm), indicating that the photocurrent maybe result from the response of single Ti₃C₂T_x MXene component. The above photoresponse characteristics can be further better understood by the energy band diagram illustrated in Fig. 5b. Because of the work function difference between GaAs and Ti₃C₂T_x, the built-in potential across the depletion region would be formed at $Ti_3C_2T_x/GaAs$ interface when both materials are contacted. Therefore, upon light illumination in the range of UV-NIR, the light is absorbed by both materials and then photogenerated carriers will be separated and collected by external electrodes, giving rise to the photocurrent in the external circuit. On the other hand, for the light with photon energy smaller than the corresponding bandgap of GaAs, Ti₃C₂T_x would mainly absorb the incident light, hot electrons excited in Ti₃C₂T_x can overcome the Schottky barrier, rendering the device capable of detecting the light with wavelength of up to 980 nm. In addition, plasmon-induced hot electrons in Ti₃C₂T_x MXene film are also responsible for infrared photoresponse. Obviously, the $Ti_3C_2T_x$ MXene film on GaAs is composed of the disordered stacking few layer nanoflakes. The dimensions of these nanoflakes are about several hundreds of nanometers with naturally high density of edges and nanometric gaps, which are considered to efficiently relax plasmonic momentum constraints and promote energized hot electron generation [15]. Consequently, the plasmon-induced hot electrons could be excited and then transit across the Schottky barrier under infrared light and then contribute to the photocurrent.

The long-term stability is also an important factor of photodetector for technological application. Thereby, in order to investigate the ambient stability of our Ti₃C₂T_x/GaAs Schottky junction photodetector, the device sample has been stored in the ambient condition without any encapsulation within one month. Intriguingly, the present device exhibits very good stability and only 3.20% decrease in the photocurrent, as shown in Fig. 6a and b. More importantly, even after more than 1000 cycles in a consecutive operation, the device can not only operate very well, but also remain its initial infrared photoresponse properties. Such good device stability could be ascribed to the excellent air stability of Ti₃C₂T_x and high-quality Ti₃C₂T_x/GaAs Schottky junction. The rise/fall time is as fast as 70.2/50.8 ms based on the response speed definition. This fast response speed is easily attributed to the strong built-in electric field at the junction interface which is conducive to the quick separation and transport of photo-generated carriers.

4. Conclusion

In summary, we have demonstrated a high-performance broadband and self-driven Ti₃C₂T_x/GaAs Schottky junction photodetector by simply dripping Ti₃C₂T_x MXene solution on a pre-defined GaAs substrate. Temperature-dependent electrical measurements were firstly conducted to demonstrate the high-quality Schottky junction electrical performance. The assembled Ti₃C₂T_x/GaAs Schottky junction exhibits a pronounced photovoltaic behavior, enabling the device operate in self-driven mode without external energy consumption. What's more, the prominent photodetection properties, including a good responsivity of ~1.46 A/W, an impressive specific detectivity of ~1.23 \times 10¹³ Jones, a high $I_{\text{light}}/I_{\text{dark}}$ ratio of 5.6×10^5 are obtained, which are superior to most of MXene based photodetectors. Significantly, owing to the broad absorption of Ti₃-C₂T_x MXene film our photodetector can detect infrared light with wavelength of to 980 nm exceeding the absorption edge of GaAs (874 nm). We believe all these impressive results confirm that the design of novel $Ti_3C_2T_x/GaAs$ Schottky junction device show the important application in the field of optoelectronics devices.

CRediT authorship contribution statement

Xiwei Zhang: Methodology, Writing - original draft, Funding acquisition. Jiahua Shao: Investigation, Data curation, Writing review & editing. Chenxi Yan: Methodology, Writing - review & editing. Xinmiao Wang: Methodology, Writing - review & editing. Yufei Wang: Methodology, Writing - review & editing. Zhihui Lu: Methodology, Writing - review & editing. Ruijie Qin: Methodology, Writing - review & editing. Xiaowen Huang: Writing - review & editing. Junlong Tian: Funding acquisition, Writing - review & editing. Longhui Zeng: Writing - review & editing.

Declaration of Competing Interest

The authors declare that they have no known competing financial interests or personal relationships that could have appeared to influence the work reported in this paper.

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